



Docket No.: M4065.0987/P987-B
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Jiutao Li, et al.

Application No.: 10/602,483

Confirmation No.: 1120

Filed: June 24, 2003

Art Unit: 2818

For: ELIMINATION OF DENDRITE
FORMATION DURING
METAL/CHALCOGENIDE GLASS
DEPOSITION

Examiner: D. Le

CHANGE OF CORRESPONDENCE ADDRESS

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Applicant respectfully notes that a Revocation of Power of Attorney and New Power of Attorney and Change of Correspondence Address, naming the below listed address as the new correspondence address in this matter, was filed in the U.S. Patent and Trademark Office on November 14, 2003. Applicant hereby respectfully requests that the new correspondence address listed below be entered into the PTO's records.

Dated: November 17, 2003

Respectfully submitted,

By 

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